

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

CHEN et al.

Atty. Ref.: 2476-36; Confirmation No. 2845

Appl. No. 10/730,382

TC/A.U. 1756

Filed: 9 December 2003

Examiner: Angebrannt Martin J.

For: REVERSIBLE PHOTOBLEACHABLE MATERIALS BASED ON NANO-SIZED  
SEMICONDUCTOR PARTICLES AND THEIR OPTICAL APPLICATIONS

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November 12, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

Responsive to the Official Action dated May 11, 2007 (for which petition is hereby  
made for any necessary extension of time), please amend the above-identified  
application as follows: